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## PATENT ABSTRACTS OF JAPAN

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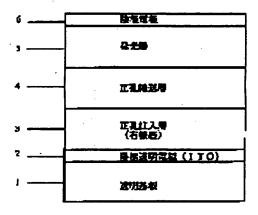
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## (54) ORGANIC ELECTROLUMINESCENCE ELEMENT

(57)Abstract:

PROBLEM TO BE SOLVED: To allow a low driving voltage regardless of the work function of a negative electrode material by doping an electron accepting compound having the property to oxidize the organic compound constituting an organic layer to the organic compound of a portion kept in contact with a positive electrode as an electron accepting dopant in vacuum by the co-deposition method.

SOLUTION: A glass substrate 1 is coated with ITO having the sheet resistance of 25  $\Omega$ /(square) as a positive transparent electrode 2, aNPD having a positive hole transportation property and ferric chloride are codeposited into a film with the thickness of 100 & angst; at the mole ratio of 1:2 at the deposition speed of 3 Å/sec under 10-6 Torr to form a positive hole injection layer 3 on the positive transparent electrode 2. The  $\alpha$  NPD is vacuum-deposited to the thickness of 500 Å on the same condition as a positive hole transportation layer 4 on the positive hole injection layer



3. Tris (8-quinolinolate) aluminum complex is formed at the thickness of 700 Å on the same condition as a luminescence layer 5. Aluminum is deposited at the thickness of 1000 Å at the deposition speed of 15 Å/sec as a back electrode 6 serving as a negative electrode. The maximum luminance of 4700 cd/m2 is obtained at 12 V.

## **LEGAL STATUS**

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